

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85660

Heiji WATANABE , et al.

Appln. No.: 10/521,311

Group Art Unit: 2815

Confirmation No.: 1690

Examiner: WARREN, MATTHEW E

Filed: January 14, 2005

For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND
MANUFACTURING APPARATUS OF THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 7, 2008, please consider the remarks as follows on the accompanying pages.

TABLE OF CONTENTS

REMARKS	2
---------------	---